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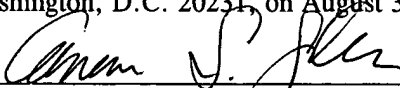
Docket: 0756-1961

12/13/01  
8-10-00  
C. Brown

**RESPONSE UNDER 37 CFR 1.116 - EXPEDITED  
PROCEDURE - EXAMINING GROUP 2811**

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on August 3, 2000.

  
Cameron S. Gilligan

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
In re PATENT application of )  
Shunpei YAMAZAKI et al. ) Group Art Unit: 2811  
Serial No. 09/295,607 ) Examiner: S. Loke  
Filed: April 22, 1999 )  
For: SEMICONDUCTOR DEVICE HAVING )  
ALUMINUM NITRIDE FILM ) Date: August 3, 2000

**AMENDMENT AFTER FINAL**

Assistant Commissioner for Patents  
Box AF  
Washington, D.C. 20231

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Sir:

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In response to the Office Action of April 3, 2000, please amend the above-identified application as follows.

**IN THE SPECIFICATION:**

Before the first sentence of the specification, please insert the following:

--This application is a Divisional of Application Serial No. 08/877,307, filed June 17, 1997, which is itself a Divisional of Application Serial No. 08/456,404, filed June 1, 1995, now U.S. Patent No. 5,650,636.--

Sub C'  
B'

CC/09/2000 KZENDIE 00000028 09295607 234.00 DP  
01 FC:103